INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)

| Docket Number (Optional) TWI-8570 | Application Number NEW | |
|--|---------------------------|--|
| Applicant(s) Michial Duff Howell et al. | | |
| Filing Date HEREWITH | Group Art Unit Unknown | |

U.S. PATENT DOCUMENTS

| *EXAMINER INITIAL | Ref | DOCUMENT NUMBER | DATE | Name | CLASS | SUBCLASS | FILING DATE |
|----------------------|------|--------------------|------------|-------------------|-------|----------|-------------|
| 91 | *AA | 3,887,392 | 06/03/1975 | Tang | 134 | 1 | 11/23/1973 |
| 70 | *AB | 4,032,750 | 06/28/1997 | Hurko | 219 | 464 | 03/26/1976 |
| | *AC | 5,049,816 | 09/17/1991 | Moslehi | 324 | 158 | 05/31/1990 |
| | *AD | 5,252,807 | 10/12/1993 | Chizinsky · | 219 | 390 | 10/23/1991 |
| | *AE | 5,261,965 | 11/16/1993 | Moslehi | 134 | 1 | 08/28/1992 |
| | *AF | 5,306,671 | 04/26/1994 | Ogawa et al. | 437 | 225 | 06/21/1991 |
| | *AG | 5,374,594 | 12/20/1994 | van de Ven et al. | 437 | 247 | 01/22/1993 |
| | *AH | 5,439,596 | 08/08/1995 | Ohmi et al. | 210 | 748 | 07/02/1992 |
| | *AI | 5,449,411 | 09/12/1995 | Fukuda et al. | 118 | 723 MP | 10/19/1993 |
| | *AJ | 5,589,421 | 12/31/1996 | Miyashita et al. | 437 | 225 | 09/01/1994 |
| | *AK_ | 5,716,207 | 02/10/1998 | Mishina et al. | 432 | 253 | 07/26/1996 |
| | *AL | 5,798,837 | 08/25/1998 | Aspnes et al. | 356 | 369 | 07/11/1997 |
| | *AM | 5,897,710 | 04/27/1999 | Sato et al. | 427 | 8 | 04/07/1998 |
| | *AN | 5,935,768 | 08/10/1999 | Biche et al. | 430 | 401 | 06/10/1997 |
| V. | *A0 | 6,056,544 | 05/02/2000 | Cho | 432 | 249 | 04/29/1999 |
| 94 | *AP | 6,286,230 | 09/11/2001 | White et al. | 34 | 403 | 09/07/1999 |
| <u> </u> | | L | | | | | |

FOREIGN PATENT DOCUMENTS

| | | DOCUMENT | | | | | TRANSLATION | |
|--------------|--------|--------------|------------|------------------------------|----------|--------|-------------|----------|
| REF | NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | YES | No | |
| <u>98/</u> | *AQ | 4-357836 | 06/04/1991 | Japan (translation included) | H01L | 21/304 | X | |
| 70 | *AR | 0 462 459 | 06/07/1991 | EPC | H01L | 21/00 | | |
| | *AS | 04357823 | 12/10/1992 | Japan (Abstract) | H01L | 21/027 | | |
| | *AT | WO 95/00681 | 01/05/1995 | PCT | C23G | 1/00 | 1 | |
| | *AU | 10-137704 | 11/08/1996 | Japan (w/o translation) | B08B | 3/12 | | X |
| | *AV | WO 98/05066 | 02/05/1998 | PCT | HOIL | 21/66 | | 1 |
| V | *AW | WO 99/02970 | 01/21/1999 | PCT | GOIN | 21/21 | | |
| <i>9</i> \$4 | *AX | WO 99/356677 | 07/15/1999 | PCT | H01L | 21/306 | <u> </u> | |
| - 0 | | | | | | | Ť | 1 |

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

| 946 | TAY | K. Imen, S.J. Lee & S.D. Allen, "Laser-assisted micron scale particle removal," Appl. Phys. Lett., Vol 58, No. 2, 14 January 1991, pp. 203-205. | | | | | |
|---------------------------|-----------------------|---|-----------------------------|---|--|--|--|
| | l <u>.</u> | <u> </u> | 0 | | | | |
| Examiner | Than | outiva - | Jugua | Date Considered 5/2/D4 | | | |
| Examiner: not in confe | Initial if ormance | citation considered, wh | ether of not citation is in | conformance with MPEP Section 609; Draw line through citation if ith next communication to applicant. | | | |